Attorney's Docket No.: <u>57017.P025</u>	_		<u>Patent</u>	
lin re the Application of: Chen. J. et al.		AMEND	AMENDMENT UNDER	
(inventor(s)) Serial No.: _07/863,791		37 C.F	37 C.F.R. § 1.116 EXPEDITED PROCEDURE	
Filed: _April 6. 1992 EXAMINING GROUP _2503				
PROCESS (title)			005)	
THE COMMISSIONER OF PATENTS AND TWAShington, D.C. 20231 Box AF	FRADEMARKS		application.	
SIR: Transmitted herewith is an Amendme	ent After Final Ac	ction for the above a	application.	
Small entity status of this application under 37 C.F.R. §§ 1.9 and 1.27 has been established.				
by a verified statement previously submitted.  A verified statement to establish small entity status under 37 C.F.R. §§ 1.9 and 1.27 is enclosed.				
No additional fee is required.  A Notice of Appeal is enclosed.	sed.			
The fee has been calculated as shown below	v:		OTHER THAN A	
(Col. 1) (Col. 2)	(Col. 3)	SMALL ENTITY	OTHER THAN A SMALL ENTITY	
Claims Highest No. Remaining Previously	Present	Rate Additional	Rate Additional	
After Amd. Paid For	Extra	Fee	Fee	
Total • Hinus	0	x11 \$	x22 \$ -0-	
Indep. • •••	0			
Claims   Minus   First Presentation of Multiple		x37 \$		
Dependent Claim(s)	<u> </u>	115 \$	+230 \$ <sup>-0</sup> -	
* If the entry in Col. 1 is less than the entry in C write "0" in Col. 3.	ol. 2, Add.	Fee \$ Add	Total J. Fee \$ -0-	
** If the "Highest No. Previously Paid For" IN THIS				
SPACE is less than 20, write "20" in this space.  *** If the "Highest No. Previously Paid For" IN THIS SPACE is less than 3, write "3" in this space.				
The "Highest No. Previously Paid For" (Total o the equivalent box in Col. 1 of a prior amendr				
A check in the amount of \$		•	·	
Applicant(s) hereby Petition(s) for an Extension of Time of month(s) pursuant				
to 37 C.F.R. § 1.136(a).  Acheckfor\$ is attached for processing fees under 37 C.F.R. § 1.17.				
Please charge my Deposit Account No. <u>02-2666</u> the amount of \$				
A duplicate copy of this sheet is enclosed.  X—— The Commissioner is hereby authorized to charge payment of the following fees associated				
with this communication or credit any overpayment to Deposit Account No. 02-2666				
(a duplicate copy of this sheet is enclosed):  X Any additional filing fees required under 37 C.F.R. § 1.16 for presentation of				
extra claims.  X Any extension or petition fees under 37 C.F/R. § 1.17.				
BLAKELY SOKOLOFF TAYLOR & ZAFMAN				
	DLAN		TLOR & ZAFIVIAIN	
Date: September 9, 1993	·	LAWKEN 1.	House	
12400 Wilshire Boulevard	Bradi	by J. Bereznak \	( )	
Seventh Floor	Reg.N	lo. 33.474		
Los Angeles, California 90025 (408) 720-8598				
I hereby certify that this correspondence is being with sufficient postage in an envelope addressed D.C. 20231	deposited with the l to the Commissione	Jnited States Postal Se r of Patents and Trader	ervice as first class mail narks, Washington,	
on September 9, 1993				
Date of Deposit	•			
Pearl E. Dworkin Name of Person Mailin	ng Correspondence		<del></del>	
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Signature	<del>/</del>	Date	(المال)	

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57017-P025

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

CHEN, J. et al.

Serial No.: 07/863,791

Filing Date: April 6, 1992

For: METHOD FOR IMPROVED

LITHOGRAPHIC PATTERNING IN A SEMICONDUCTOR FABRICATION

**PROCESS** 

<u>Patent</u>

Dodson, S.

Art Unit:

Examiner:

1503



## **Amendment To Final Office Action**

Box AF Hon. Commissioner of Patents and Trademarks Washington, D.C. 20231

Sirs:

In response to the Office Action mailed August 6, 1993, please consider the following amendment and consider the following remarks.

## IN THE CLAIMS:

- 1. (Twice Amended) A method of <u>lithographically</u> printing a twodimensional feature on a substrate, said feature having first an second edges spaced in close proximity to one another, said method comprising the steps of:
  - (a) depositing a radiation-sensitive material on said substrate;
- (b) providing a first mask image segment which corresponds to said first edge;
- (c) exposing said first mask image segment with radiation using an imaging tool to produce a first pattern edge gradient, said first pattern edge gradient defining said first edge of said two-dimensional feature in said material;
- (d) providing a second mask image segment which corresponds to said second edge;